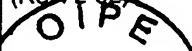


| | | | |
|---|--|--|--------------------------|
| FORM PTO-1449 (Rev. 2-92)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | ATTY. DOCKET NO. 34170 | | SERIAL NO. 10/672,210 |
| | INFORMATION DISCLOSURE STATEMENT BY APPLICANT | | |
| | FILING DATE: 9/26/2003 | | GROUP: 4631 2878 |

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

| | | | |
|---|--|-------------------------------------|--------------------------|
| FORM PTO-1449 (Rev. 2-32) | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | ATTY. DOCKET NO. 33063 | SERIAL NO. 10/672,210 |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary) | | APPLICANT: Maurice Lee Smith et al. | |
| | | FILING DATE: 9/26/2003 | GROUP: 2878 |

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

| | | |
|---|--|--|
| 1 | | "Oak Ridge claims sensitivity record for Si MEMS sensor"; June 23, 2003 article in Electronic Engineering Times; Author R. Colin Johnson, page 49. |
| | | |
| | | |
| | | |
| | | |

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Exr. Le

Date: 2/06